

Docket No.: 0051-0217P
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Tomoyuki KOJIMA et al.

Application No.: 10/758,012

Confirmation No.: 5749

Filed: January 16, 2004

Art Unit: 3753

For: VACUUM SUCTION SYSTEM AND
METHOD OF CONTROLLING THE SAME

Examiner: W. M. MCCALISTER

AMENDMENT UNDER 37 C.F.R.1.116

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

November 24, 2010

Sir:

In response to the Office Action mailed August 27, 2010, the following amendments and remarks are respectfully submitted in connection with the above-identified application:

This Paper includes

Amendments to the Claims, and

Remarks.